

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN发明: Won et al.

Serial No.: 10/800,826

Filed: March 15, 2004

For: METHODS OF FORMING RUTHENIUM FILM BY CHANGING PROCESS
CONDITIONS DURING CHEMICAL VAPOR DEPOSITION AND RUTHENIUM
FILMS FORMED THEREBY

Confirmation No.: 1388

Group Art Unit: 2822

Examiner: David E. Graybill

Date: March 30, 2006

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE TO RESTRICTION REQUIREMENT

Sirs:

Applicants provide the present Amendment to address the issues raised in the Office Action mailed November 30, 2005.

It is not believed that an extension of time and/or additional fee(s)-including fees for net addition of claims-are required, beyond those that may otherwise be provided for in documents accompanying this paper. In the event, however, that an extension of time is necessary to allow consideration of this paper, such an extension is hereby petitioned under 37 C.F.R. §1.136(a). Any additional fees believed to be due in connection with this paper may be charged to our Deposit Account No. 50-0220.

Amendments to the Claims are reflected in the listing of claims, which begins on page 3 of this paper.

Remarks begin on page 4 of this paper.